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STATEMENT BY APPLICANT**  
*( Not for submission under 37 CFR 1.99)*

Application Number	10550924
Filing Date	2006-10-10
First Named Inventor	Mitsuru Furusawa
Art Unit	1633
Examiner Name	Michael D. Burkhart
Attorney Docket Number	38573/4

**U.S.PATENTS**

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	1	2004225648	AU	B2	2004-10-14	Neo-Morgan Laboratory	Notice of Acceptance	<input type="checkbox"/>

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1	LI et al., "Sensitivity to Phosphonoacetic Acid: A New Phenotype to Probe DNA Polymerase-delta in <i>Saccharomyces cerevisiae</i> ," <i>Genetics</i> , Vol. 170:569-580, June 2005.	<input type="checkbox"/>
2	MCELHINNY et al., "Inefficient Proofreading and Biased Error Rates During Inaccurate DNA Synthesis By a Mutant Derivative of <i>Saccharomyces cerevisiae</i> DNA Polymerase-delta," <i>J. Biol. Chem.</i> , Vol. 282:2324-2332, Jan 2007.	<input type="checkbox"/>
3	VENKATESAN et al., "Mutator Phenotypes Caused by Substitution at a Conserved Motif A Residue in Eukaryotic DNA Polymerase-delta," <i>J. Biol. Chem.</i> , Vol. 281:4486-4494, Feb 2006.	<input type="checkbox"/>

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